

IN THE SPECIFICATION:

Please amend the paragraphs in the specification as follows:

[0035] Fig. 11 ~~Fig. 10~~ is a block diagram showing the construction of a fourth embodiment (OBIRCH measuring equipment) of a laser beam inspection apparatus according to the present invention.

[0037] Fig. 2 ~~Fig. 1~~ is a block diagram showing the construction of an OBIRCH measuring equipment as a first embodiment according to the present invention.

[0038] As shown in Fig. 2 ~~Fig. 1~~, in the OBIRCH measuring equipment according to the first embodiment, upon the optical path of a laser beam L emitted from a laser source 1 that is a light source, a laser scanning unit 2 for raster-scanning the laser beam L in a two-dimensional direction perpendicular to the optical path, and a microscope 3 for condensing the scanned laser beam L at a micro-spot diameter are arranged.